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## A nisotropic G aA s island phase grow n on at G aP : spontaneously form ed quantum w ire array

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A dense phase of G aA s wires form s in the early stages of strained growth on G aP, assembling from elongated Stranski-K rastanow islands. The electron di raction during growth is consistent with long, faceted G aA s islands that are anisotropically deformed without dislocations. The lateral wire period and long shapes are not predicted by published models, though we conclude that the island orientation is picked out by facet energy inequivalencies not present in the analogous system of G e islands on Si.

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Crystal growth on a substrate with a smaller lattice spacing can initially give sm all regular islands without crystal dislocations. Two examples are the tens-ofm ono layers-high G e islands that form on Si [1] and InAs islands that form on GaAs [2,3]. The layer-substrate system lowers its energy when the islands relax towards their larger lattice constant at the expense of both locally straining the substrate and increasing the surface area. The islands can behave as an equilibrium morphological phase [2,4] with narrow size distributions around speci c sizes [5] that often do not show appreciable coarsening. Beyond being a recently appreciated crystal grow th phenom enon, interest in the topic stem s from the technological in portance of grow ing strained sem iconductor layers. Som e combinations, such as InAs on GaAs, exhibit appreciable quantum con nem ent of electrons and holes, so the work has been further motivated by the study and possible application of island optical and electrical properties.

The relative contributions of grow th kinetics and equilibrium thermodynamics to island formation have not been settled. Some hypotheses for the growth kinetics selecting the island size include that a strain-related diffusion barrier prevents atoms from moving onto larger islands [6,7] or that a nucleation barrier for additional lattice-planes on island facets limits growth [8]. An equilibrium -based idea for explaining the island size and size distribution is that nearly uniform one-monolayerhigh precursor islands form at equilibrium and then collapse and roll up to give the observed islands [9]. In another approach to explain the elongated islands found in som e instances, for exam ple G e islands on Si [8], one model xes the island height and m in im izes the sum of strain and surface energy as a function of size and aspect ratio to give symmetric islands at an equilibrium

size and elongated islands when the islands grow beyond the preferred size [10].

W e report on G aAs islands grown on G aP, which can be viewed as the III-V sem iconductor analog of G e on Si, since the respective lattice constants are very close to one another. The distinguishing behavior of this new system is that very long islands assemble into a dense, stable, corrugated phase with speci c orientation and speci c lateral period. A tom ic force m icrographs for sam ples with di erent GaAs deposition thicknesses, but otherw ise m ade w ith the sam e grow th tem peratures, pressures and rates, show that the corrugations have appeared at a thickness near three m onolayers and still dom inate the m orphology at approxim ately seven m onolayers of deposition. The 13 nm corrugation period is in the range desired for sem iconductor quantum wires with strong carrier con nem ent to one dimension. Electron di raction from the corrugated phase shows GaAs crystals com pressed to the G aP lattice constant in the long direction, having the GaAs lattice constant perpendicular to the wire in the substrate plane, and being extended beyond the G aA s lattice constant perpendicular to the substrate. The present wire phase is not found to be predicted by an elasticity model for strained corrugated surfaces [13], and we argue that the out-of-equilibrium requirem ent for the long islands of R ef. [10] are not m et under the present conditions. A fter considering the several reported orientations of other elongated islands, we conclude that the intrinsic surface stress anisotropy does not select island orientation but that inequivalent facet energies do. We modify the model of Ref. [10] to account for the wire phase orientation by including inequivalent island facet surface energies.

The experiments consisted of seven samples with G aAs depositions of 0, 0.84, 1.7, 3.3, 5.0, 6.7, and 10 m onolayers m ade in a chemical beam epitaxy machine of our own design. In this growth technique, molecular beams of chemical precursors impinge on a heated substrate for reaction and epitaxial growth. For both G aAs and G aP, the growth rate is determined by the arrival of G a atoms while a slight overpressure of the respective As or P molecular beam is maintained. The precursors were triethylgallium (TEG a) and therm ally cracked tertiary-butylarsine (TBAs) and tertiary-butylphosphine (TBP). For all samples a 180 nm G aP bu er layer was rst grown on at (0.2) S-doped (001) G aP substrates at 640 C. The G aAs grow th conditions were chosen to emphasize equilibrium behavior; the temperature was 580 C and the rate was 0.056 m onolayers/s. Re ection high-energy electron di raction (RHEED) intensity patterns were recorded during each growth [12]. Atom ic force m icroscopy (AFM) m easurements in tapping mode were done outside the vacuum system.

FIG.1. AFM micrographs for di erent G aAs deposition amounts. a. EpitaxialG aP surface (0 monolayers of G aAs). b.0.84 G aAs monolayers showing sm allelongated islands.c. Corrugated surface after 5.0 G aAs monolayers.d. Irregularly shaped islands after 10 G aAs monolayers.

The AFM images shown in Fig. 1 follow the surface morphology with increasing deposition, displaying data from the 0, 0.84, 5.0, and 10 m onolayer samples. M onolayer-high steps are apparent on the GaP surface of Fig.1 (a), which was not exposed to the Asmolecular beam. At 0.84 m on olayers of G aAs, Fig. 1(b), islands have form ed with heights of up to 6 m onolayers, or 2 nm. The islands do not exhibit a sharply de ned size or shape, though there is a clear tendency for elongation in the [110] direction. The widths in the [110] direction are 20 to 27 nm , and m any islands have in-plane aspect ratios close to 4:1. The density of islands is  $1 \times 10^{10}$  cm<sup>2</sup>. The density and length of the islands increase with deposition until condensing into the corrugated phase shown in Fig. 1(c) for the 5.0 m on olayer deposition sample. The corrugation spacing varies from 10 to 15 nm. Many of the G aA s w ire structures can be seen to extend for m ore than 0.25 m.

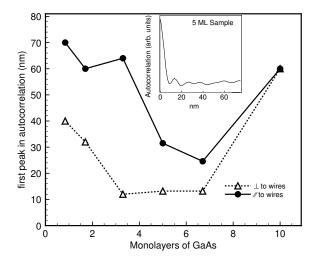


FIG.2. The rst autocorrelation peak of the surface feature heights as a function of deposited amount of G aAs. The peak is a measure of the separation of the nearest neighbor corrugations. The inset shows the autocorrelation from the 5.0 m onolayer sample taken perpendicular to the wires.

The measured heights of the corrugations are close to 2 nm. If the actual island heights are greater, the close lateral spacing could be preventing the AFM tip from reaching the substrate between them. Though not shown in Fig. 1, the corrugations have appeared and already cover approxim ately 90 % of the surface for the 3.3 m onolayer deposition. The corrugations sim ilarly dom - inate the morphology of the 6.7 m onolayer sam ple, also not shown here, though irregular com pact islands have begun to form. Larger, irregular com pact islands with heights of up to 13 nm cover the 10 m onolayer sam ple of Fig. 1(d).

Figure 2 sum m arizes autocorrelations of A FM feature heights taken for all of the sam ples. Autocorrelation was chosen to facilitate the comparison of island separations in non-periodic island morphologies with those in the approximately periodic corrugations. Height auto correlations were calculated for each row (column) of data making up the image and then summed to give 1D average autocorrelations parallel (perpendicular) to the wires. As an example, the result for the corrugated surface of Fig. 1 (c) perpendicular to the wires is given in the inset of Fig. 2. The approximate periodicity in the inset re ects the approxim ate periodicity of the corrugations. The rst peak in the autocorrelation is a measure of the average nearest neighbor separation of the islands parallel and perpendicular to the wires and is plotted in Fig.2 for all samples. The 40 nm and 70 nm peaks of the 0.84 m on olayer sample re ect the  $10^{10} \text{ cm}^2$  density of isolated islands, where the asymmetric values are due to the elongated island shapes. The [110] island-island separation decreases with deposition until the appearance of the corrugations near 3 m onolayers, where it reaches 13 nm and rem ains constant until around 7 m onolayers. Throughout the corrugated phase the peak in the [110] direction decreases as the number of compact irregularities along the wires increases. At 10 m onolayers the st peaks are at 60 nm for both the [110] and the [110] directions, re ecting the statistical isotropy of both shape and positional correlations of the large irregular islands.

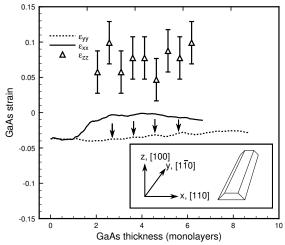


FIG.3. D iagonal strain tensor components of the GaAs material measured with RHEED and plotted as a function of GaAs layer thickness for three di erent crystal directions. The inset depicts the strain component orientations with respect to the islands.

The RHEED patterns recorded during growth give a m easure in reciprocal space of the evolving surface m orphology [12]. When di raction was recorded with the electron beam perpendicular to the wires, the di raction pattern changed continuously from the re ectiondi raction rods of a 2-fold reconstructed surface to the transm ission-di raction spots of the G aA s islands. W ith the beam parallel to the wires, a similar continuous transition was recorded from an initial 4-fold pattern, though chevron-shaped features at the transm ission spots were also seen. The chevron angle of approxim ately 35 would correspond to island facets along the wires of 114 orientation.

The position of the di raction features depends on the island strain. Estimates of the diagonal strain tensor com ponents of the islands are plotted versus deposition thickness in Fig. 3, where GaP rod separations were used as references. For strains parallel to the surface, epsilon<sub>xx</sub> perpendicular to the wires and "vy along the wires, the (10) to (10) rod separation was measured at positions corresponding to 3D di raction. Transmission spot separations perpendicular to the surface gave the strain perpendicular to the surface, "zz. A long the wires, in the [110] direction, the islands stay strained to close to the G aP substrate throughout the recorded 10 m onolayers of deposition. In the [110] direction, perpendicular to the wire axis, the lattice constant begins to relax to that of G aA s after approxim ately one m onolayer, once the islands have form ed and are contributing a signi cant amount of 3D di raction intensity. By 3 or 4 m onolayers, the sides of the islands have bulged out to close to the G aA s lattice constant. The [001] tensile island strain perpendicular to the surface in the corrugated phase is 0.06. Taken together, the strain m easurem ents in the three perpendicular directions indicate that the long islands in the corrugated phase are elastically deform ed, implying no crystal dislocations. The present estim ates treat the di raction feature positions as giving a measure of uniform ly strained islands. A more accurate treatment would model the nonuniform strain in the islands, the non-uniform penetration of the electron beam into the islands, and dynam ical scattering processes during di raction. The Arrows in Fig. 3 points out oscillations as function of monolayer completion, wich have been reported previously for the InA s/G aAs system by [11]. M ore detailed RHEED analysis can be found in Ref. [12].

The period found for the dense G aAs wire phase reported here can be compared with a continuum elasticity model that relates lattice m ism atch with surface corrugation period [13]. In that model, a local minimum was found in the Helmholtz free energy, given by  $E_T = E_{facets} + E_{edges} + E_{elastic}$ . Here  $E_{facets}$  is the free energy of the facets,  $E_{edges}$  is an energy associated with the facet edges and  $E_{elastic}$  is an elastic strain energy due to edges and lattice m ism atch. A local energy minimum corresponding to the corrugated surface was found only to exist for a lattice m ism atch that is less than a critical

value determ ined by the corrugation size and material parameters. The criticalm ism atch is

$$\frac{a}{a}_{c} = c \frac{xx}{L_{0}}; \qquad (1)$$

where  $_{xx}$  is the facet intrinsic surface stress perpendicular to the edges,  $L_0$  is the period of the faceting, and c is a constant dependent on the elastic m oduli and geom etry. The present G aAs corrugated surface has  $L_0 = 13$  nm. Here we use the same approximate value of  $_{xx} = 100$  m eV / A<sup>2</sup> as in Ref. [13] and nd a critical lattice m ism atch of  $\frac{a}{a}_{c} = 2:3 \quad 10^{-3}$ . This upper bound is an order of m agnitude smaller than the present G aA s/G aP lattice m ism atch of  $\frac{a}{a} = 3:7 \quad 10^{-2}$ . A lthough the corrugated surfaces treated by the m odel have obvious sim ilarities to the present G aA s surface, the large m ism atch and short period m ean that thism odel can not be directly applied.

The shape of the long narrow islands of G aAs on G aP can be compared with a model for long rectangular islands. The island energy was taken as  $E_T = E_{facets} + E_{elastic}$  [10], and changes in size and in-plane aspect ratio were considered. For a xed island height, an equilibrium size was found, and the shape of this optim al island was a sym metric square. How ever, if islands larger than the equilibrium size were considered, then the optim al shape was found to be asym metric with approxim ately constant width but increasing length with size. It was suggested that isolated islands become over ripe during grow th when they are too far apart to exchange atom s through di usion. W hen the height is not

xed, the square island always has the lower energy [14]. Consistent with the model requirements, the height of the GaAs islands remains approximately constant when they form at low coverage and throughout the corrugated phase. In accord with the model prediction, the width of the islands remains approximately constant while their length increases, apparently only limited by irregularities. Still, the 13 nm corrugations are sm all enough that islands should easily exchange atom s through di usion. For com parison, appreciable di usive m ass transport occurs over distances greater than 100 nm during GaAs growth on lithographically patterned substrates. At our slow deposition rate and warm temperature, the islands should easily exchange atom s and the m odel would predict sym m etric islands. Thus, the corrugated surface represents an optim alequilibrium shape in itselfwithout any over ripening. The result of Ref. [10] does not account for the shape of these islands because the predicted shape would be symmetric for equilibrium conditions.

The orientation of the wires might be determined by several contributions. One possibility is the strongly anisotropic surface stress which is aligned with the dimers of the reconstructed (001) surface. On Si, where the dimer orientation rotates by 90 with each atom ic surface step, the elastic interaction is su cient to spontaneously rearrange a at surface into alternating domains

[17]. Here we make orientation comparisons with other elongated island system s. The analogous Ge islands on Siare 2 to 4 nm high, 25 nm wide, and can be over 100 nm long [8]. Despite the sim ilar dimensions, the Ge islands grow with two orientations, along both [010] and [100], which are 45 to the present [110] oriented GaAs islands. In another III-V system, InSb islands on InP (10.4% m ism atch) show a shape transition with increasing size to elongation along [110], where the islands are 10 nm high, 30 nm wide, and 90 nm long [15]. As a closer m ism atch analog (3.2%) having the same colum n-V elements, InAs islands formed on InP substrates show a shape transition with larger symmetric islands transform ing to sm aller elongated islands. The InAs islands on InP are 3 to 4 nm high, 30 nm wide, over 100 nm long, and aligned in the [110] direction [16]. For both the III-V and IV sem iconductors, the dimers are parallel to h110i directions. The III-V materials typically have Vterm inated surfaces with dim er axes parallel to the [110] direction. Because islands with many orientations with respect to the intrinsic surface stress eld are reported, we conclude that the stress an isotropy does not play the determ ining role in island orientation.

The di erence in facet surface energies m ay be picking the island orientation. The G e island facet energies islands will re ect the cubic crystal sym m etry, and consistent with this two perpendicular orientations are found. The facet energies of the polar III-V com pounds will re-

ect the lack of inversion sym m etry, with the largest difference between III- and V-term inated flllg surfaces. W hile the model of R ef. [10] does not account for long equilibrium shapes, them odelcan be modiled to account for inequivalent orientations by introducing two facet surface energies,  $E_A$  and  $E_B$ . The the total energy divided by the island volum e is then

$$\frac{E}{V} = \frac{2}{\sin} \quad \frac{E_{A}}{t} + \frac{E_{B}}{s} + E_{s} \cot (s^{1} + t^{1})$$

$$2ch \quad s^{1} \ln \frac{s}{h} + t^{1} \ln \frac{t}{h} ; \qquad (2)$$

with  $E_s$  the top facet surface energy; c a constant containing elastic moduli; s, t, and h the two island side lengths and the height; and a constant containing the facet angle . The inequivalent facet surface energies that appear in the st term serve to provide the orientational bias. As expected, the longer island side will have the lower surface energy.

To conclude, a dense G aAs wire phase was found to form on G aP. D i raction patterns show elastically strained islands with di raction features consistent with re ection from island facets. The long G aAs islands are similar to G e islands found on Si. Though a crucial difference between the two systems m ay be that the G aAs wires grow only in one orientation, allowing the condensation into a dense ordered phase. The orientation of elongated islands was deduced to be due to di erences in facet energies rather than to surface stress anisotropies. A fler com parison with available theories, open questions include: W hat picks the size and what gives the long shapes?

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